

# IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**In re Application of :**

Hong-Qiang Lu  
Wei-Jen Hsia  
Wilbur Catabay



**Serial No. :**

09/896,363

**Group Art Unit :**

2823

**Filed :**

June 28, 2001

**Examiner :**

Toledo, Fernando L.

**For :**

Dual Layer Barrier Film Techniques  
To Prevent Resist Poisoning

**Atty Docket :**

LSI1P167 / 01-206

I hereby certify that this correspondence is being deposited with the U.S. Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on the date below:

Connie Del Castillo

8/11/04 *Connie Del Castillo*  
Date Signature

**SUBMISSION OF FORMAL DRAWINGS PURSUANT TO 37 C.F.R. §1.85**

**Official Draftsman**

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Applicant hereby substitutes the enclosed formal drawings for those presently in the above referenced application.

LSI Logic Corporation  
1621 Barber Lane, MS D-106  
Milipitas, CA 95035  
408-433-7475

Respectfully submitted,

Timothy Croll

Reg. No. 36,771

Date: 4 AUG 04